What Is Claimed Is:

1. A method of manufacturing a vertical feed through in a substrate comprising:

providing an electrical contact cap in a hole in a substrate, wherein the cap extends

partially into the hole and partially outside the hole, wherein a portion of the hole is open for

insertion of a probe on a second substrate to electrically contact the probe with the cap in the

hole.

2. The method of claim 1 wherein the step of providing an electrical contact cap in a hole of

the substrate comprises heating the substrate made up of a green sheet of ceramic to form a

ceramic material around the cap.

3. The method of claim 2, wherein the cap is pressed into the hole formed in the green sheet

prior to heating.

4. The method of claim 1 wherein the cap includes an opening with a resilient spring probe

inserted in the opening.

5. The method of claim 1 further comprising plating at least a portion of the hole with an

electrically conductive material.

6. The method of claim 1 wherein the cap comprises a laterally protruding portion

extending into the substrate to hold the cap within the substrate.

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7. The method of claim 1 wherein the cap comprises a first cylindrical region extending

outside the substrate having a greater diameter than a second cylindrical region provided in the

hole of the substrate, wherein a laterally protruding regions extend from the second cylindrical

region to secure the cap within the substrate.

8. A method for manufacturing a vertical feed through in a substrate comprising:

stacking a first electrical contact and a sacrificial element to enable forming a feed

through path;

forming a dielectric material making up the substrate around the first electrical contact

and the sacrificial element;

removing the sacrificial element; and

plugging a second electrical contact element into an opening left by the sacrificial

element to electrically contact the first electrical contact.

9. The method of claim 8 wherein the step of forming a dielectric material comprises

inserting the first electrical contact and the sacrificial element into a hole provided in a green

sheet ceramic and heating the green sheet to form a ceramic material.

10. The method of claim 8, wherein the first electrical contact comprises a first portion

provided in the hole of the substrate and a second portion extending outside the substrate

supporting a probe.

11. The method of claim 10, wherein the probe includes a slot enabling the probe to be spring

compressed.

12. The method of claim 10, wherein the first portion includes a portion protruding laterally into

the dielectric material to secure the first contact within the hole.

13. The method of claim 10, wherein the first portion includes an indentation for engaging a

protrusion from the dielectric material to secure the first contact within the hole.

14. The method of claim 8, wherein the second electrical contact comprises a first portion for

engaging the hole in the substrate and a second portion for extending outside the substrate

supporting a probe.

15. The method of claim 8, wherein the second electrical contact element comprises a

decoupling capacitor.

16. The method of claim 15 further comprising providing a spring clip attached to the

substrate to engage the decoupling capacitor to secure the decoupling capacitor within the hole.

17. The method of claim 16 further comprising the step of forming the spring clip in an

opening of the sacrificial material prior to removing the sacrificial material.

18. A substrate comprising:

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a dielectric layer with a hole extending through the dielectric layer; and

a first electrical contact having a first portion provided in the hole of the substrate

securely encapuslated by the substrate and a second portion extending outside the substrate.

19. The substrate of claim 18, wherein the dielectric layer is formed from a green sheet of

ceramic.

20. The substrate of claim 18 further comprising:

a second electrical contact comprising a first portion provided in the hole electrically

connecting to the first electrical contact, and a second portion for extending outside the substrate

supporting a probe, wherein the first portion of the second electrical contact includes an

engaging element for securing the second electrical contact within the hole of the dielectric.